

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10064208	FILING DATE 06/21/2002	CLASS 430	SUBCLASS 30	GAU 1756	EXAMINER Young
**APPLICANTS: Chen Kuo-Tso;					
**CONTINUING DATA VERIFIED: <i>None</i>					
** FOREIGN APPLICATIONS VERIFIED: TAIWAN 90130498 12/10/2001					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed 35 USC 119 conditions met		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO 8309-US-PA	
Verified and Acknowledged Examiners's initials <i>Chung</i>					
TITLE : Substrate exposure apparatus and method					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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